

Docket No.: 060188-0766



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Customer Number: 20277

Taiji NODA

Confirmation Number: 2607

Application No.: 10/775,122

Group Art Unit: 2812

Filed: February 11, 2004

Examiner: LEE, Cheung

For: SEMICONDUCTOR DEVICE AND FABRICATION METHOD THEREFOR

Mail Stop Amendment  
Honorable Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.

- ☒ No additional fee is required.  
☐ Applicant is entitled to small entity status under 37 CFR 1.27  
☒ Also attached: Certified Translation of JP 2003-056860

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	17	20	0	\$50.00 =	\$0.00
Independent Claims	2	3	0	\$200.00 =	\$0.00
Multiple dependent claims newly presented					\$0.00
Fee for extension of time					\$0.00
IDS and PTO Form 1449 with 3 references					\$180.00
Total of Above Calculations					\$180.00

- ☒ Please charge my Deposit Account No. 500417 in the amount of \$180.00. An additional copy of this transmittal sheet is submitted herewith.
- ☒ The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

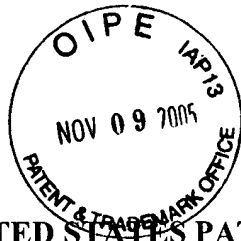
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Date: November 9, 2005

Please recognize our Customer No. 20277 as our  
correspondence address.

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**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	Customer Number: 20277
Taiji NODA	:	Confirmation Number: 2607
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**AMENDMENT**

Mail Stop Amendment  
Honorable Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 9, 2005, having a three-month shortened statutory period for response set to expire on November 9, 2005, please amend the above-identified application as follows: